

**Innovative Furnace Technologies** 

# AT A GLANCE Innovative F

- Temperature Range up to: 1000 °C
- 2" product clearance
- Belt Speeds: 8 80 inches/min
- Alloy Nichrome belt material for long belt life with 1000 °C zone temperatures
- Controlled Atmosphere Capability ( < 8 ppm Oxygen)</li>
- Energy efficient
- Low tension, vibration-free transport system
- Top removable panels allow complete access to the chamber
- PLC for furnace control with Industrial PC for HMI
- Internet link to PLC for factory assistance with customer site
- Color coded graphical user interface with links to factory technical support
- Temperature differentials up to 300 °C between adjacent zones can be achieved
- Easy-access, pull-out electrical drawers equipped with troubleshooting aids and spare parts
- Class 1000 Clean Room Compatible

# TF618X Infrared Furnace



# A Safe, Reliable, Flexible Furnace for thermal processes requiring controlled atmosphere . . . . .

The TF618X provides a safe, repeatable process capability for thermal processes requiring a controlled atmosphere Forming gas atmospheres. The furnace zones can be supplied with 100%  $N_2$  or Forming Gas up to 4%.  $N_2$  is supplied to the baffle areas to isolate the chamber from ambient air . It is capable of heating up from ambient to 950  $^{\circ}$ C and stabilize with tight temperature control in less than 30 minutes. The heat up rate and rapid cool down capability make this furnace ideal for manufacturing operations requiring multiple profile change -overs or a short production utilization during a single production day.

TP Solar, Inc designs equipment for easy access and low maintenance to ensure overall reliability and highest customer satisfaction.

16310 Downey Ave Paramount CA 90723 ,USA Phone: 562-808-2171

Fax: 562-529-2483 sales@tpsolar.com



#### **Innovative Furnace Technologies**

Furnace Configuration	Metric Units	English Units	
Overall Length	7000 mm	275 in	
Overall Width	1270 mm	50 in	
Load Station	600 mm	24 in	
Unload Station	600 mm	24 in	
Net Weight	TBD	!	
Shipping Weight (Crated)	TBD	;	
Parts Clearance	50.8 mm	2 in	
Entrance Baffle	400 mm	15.74 in	
Heated Length ( 4 Zones)	1524 mm	60 in	
Transition Baffle	400 mm	15.74 in	
Cooling Length	2286 mm	90 in	
Fan Cooling Module	1206 mm	47.5 in	
Maximum Temperature (Zones 1 to 4)	1000 °C	1832 °F	
		;	
Electrical		!	
Voltage:	380-480 VAC/3 Ph/50-60 Hz		
Peak Power	120 kw		
Lockable Safety Disconnect	Standard		
Process Atmosphere Gas			
Nitrogen @ 75 psi max	2880 SCFH		
Forming Gas, Non Combustible @ 75 psi max (Furnace Zones Only Plus 1st Transition Tunnel)	1200 SCFH		
Cooling Water Requirements			
Typical Flow @ 70 psi max (di-ionized recommended)	Optional		
Recommended Inlet Temperature	10 - 20 °C	50 - 68 °F	
Transport System (Low tension, vibration free)			
Belt Speed	8 - 80 ipm		
Belt Width	18 in		
Speed Control/Accuracy	Closed-Loop	Closed-Loop / ± 0.5 %	

#### Standard Features Included in the Base Price

Interface Rollers Oxygen Analyzer

Rack-mounted Industrial Computer

Light Tower

Handshake (Smema Optional)

Lockable Safety Interlock

Load/ Unload Stations (400mm each)

High Voltage Operation 380-480 V / 3 Ph / 50-60 Hz

Spare Parts Kit (One Year)

Uninterruptible Power Supply (PLC & PC)

Water Cooling

**Element Monitor** 

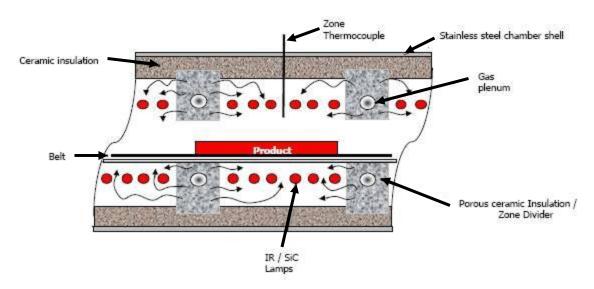
Controlled Atmosphere Capability ( < 8 ppm  $O_2$  )



#### **Innovative Furnace Technologies**

Patent Pending

### **Cover Gas Delivery Method**



A proven  $N_2$  delivery system enables very low  $O_2$  concentrations within the chamber.  $N_2$  enters the chamber system through multiple flow meters, via multiple internal zone dividers and through end baffles. All  $N_2$  supplies are separately adjustable to compensate for variations in processed product.

## Other Design Features of the TF-618X

- Thicker, less permeable insulation
- Reinforced zone dividers
- Dual exhaust
- Removable top for chamber access

## Applications for the TF-618X

- Co-fired Ceramic Technology for producing electronic packages such as:
  - Pin Grid Array (PGA)
  - \* Quad Flat Packs (QFP)
  - \* LAN Grid Array
  - Leadless Chip Carriers
  - \* Multilayer Ceramic Inserts (MLC)
- Glass to Metal Seal Technology Applications
- Brazing operations

